

Notice of References Cited			Application No. 61032,392	Applicant(s) Nakamura et al		
			Examiner RCSchilling	Group Art Unit 1752		
			Page ____ of ____			
U.S. PATENT DOCUMENTS						
*	DOCUMENT NO.	DATE	NAME		CLASS	SUBCLASS
A						
B						
C						
D						
E						
F						
G						
H						
I						
J						
K						
L						
M						
FOREIGN PATENT DOCUMENTS						
*	DOCUMENT NO.	DATE	COUNTRY	NAME	CLASS	SUBCLASS
N	2000/355177	12/2000	Japan	Takahashi	—	
O	2001/310,491	11/2001	Japan	Wachi et al	—	
P	2001/328287	11/2001	Japan	Wachi et al	—	
Q						
R						
S						
T						
NON-PATENT DOCUMENTS						
*	DOCUMENT (Including Author, Title, Source, and Pertinent Pages)				DATE	
U						
V						
W						
X						

^o A copy of this reference is not being furnished with this Office action.
(See Manual of Patent Examining Procedure, Section 707.05(a).)